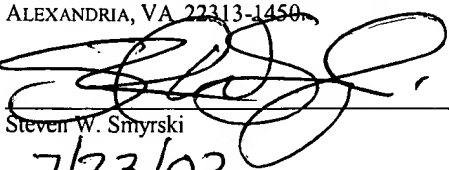




I CERTIFY THAT ON JULY 23, 2003, WHICH IS THE DATE I AM SIGNING THIS CERTIFICATE, THIS CORRESPONDENCE AND IDENTIFIED ENCLOSURES ARE BEING DEPOSITED IN THE UNITED STATES POSTAL SERVICE, POSTAGE PAID FIRST CLASS, IN AN ENVELOPE ADDRESSED TO: COMMISSIONER FOR PATENTS, P.O. Box 1450, ALEXANDRIA, VA 22313-1450.


Steven W. Smyrski

Date 7/23/03

#7/A 2877
8/12/03
PATENT
Atty Docket No. KLAC0003

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

DIETER MUELLER ET AL.

Title: COPPER CMP FLATNESS
MONITOR USING GRAZING INCIDENCE
INTERFEROMETRY

Serial No.: 09/693,614

Filed: October 20, 2000

Group Art Unit: 2877

Examiner: Hwa S. Lee

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 23, 2003, please enter the following amendments and consider the following remarks in connection with the above-identified patent application.